



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **INOUE, et al.**

Serial No.: **09/228,148**

Filed: **January 11, 1999**

Group Art Unit: **2823**

Examiner: **MALDONADO, Julio J.**

P.T.O. Confirmation No.: **7239**

For: **SEMICONDUCTOR DEVICE INCLUDING AN INSULATION FILM ON A CONDUCTIVE LAYER AND MANUFACTURING METHOD THEREOF**

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

September 29, 2003

Sir:

In response to the Office Action dated **June 27, 2003**, please amend the above-identified application as follows:

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